

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :

Yasuhiko NARA et al.

Serial No.

09/450,856

Filed

29 November 1999

For

INSPECTION METHOD, APPARATUS AND SYSTEM FOR

CIRCUIT PATTERN

Group Art Unit

2877

ASSISTANT COMMISSIONER FOR PATENTS Washington, DC 20231

CLAIM TO CONVENTION PRIORITY UNDER 35 U.S.C. § 119

SIR:

Applicants hereby claim the Convention Priority Dates of Japanese Patent Applications Nos. 10-340292, 10-340293, 10-340294, 10-340295, 10-340296, and 10-340297, all filed 30 November 1998, and No. 10-367710 filed 24 December 1998, respectively. To complete the claim to the Convention Priority Dates, certified copies of said Japanese Patent Applications are submitted herewith.

Respectfully submitted,

Dated: 11 February 2000

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